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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: SO IK BAE, YOSHINOBU NAKADA and KENICHI KANEKO

Application No.: 10/525,442

Confirmation 3831

No:

Filed: February 24, 2005

Group No.:

Examiner

Unknown

For: METHOD FOR ELIMINATING BORON CONTAMINATION IN ANNEALED WAFER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: SO IK BAE
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Second applicant: YOSHINOBU NAKADA
Citizenship: JAPAN
Residence: ~~Tokyo, JAPAN~~ Ageo-shi, Japan

Third applicant: KENICHI KANEKO
Citizenship: JAPAN
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2. Assignee information


The assignee(s) of this application is/are:

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Extent of interest of assignee in application: 100%

Date: September 21, 2005

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